

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
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HIROSHI TOYODA ET AL.)	
)	
Application No.: Unknown)	Prior Group Art Unit: 2811
)	
Filed: February 12, 2004)	Prior Examiner: H. Vu
)	
For: SEMICONDUCTOR DEVICE)	Divisional Application of U.S. Patent
AND MANUFACTURING)	Application Serial No. 10/084,065, filed
METHOD OF SEMICONDUCTOR)	February 28, 2002
DEVICE)	

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

PRELIMINARY AMENDMENT

Please amend the above-identified patent application as follows:

Amendments to the Specification are included in this paper.

Amendments to the Claims are reflected in the listing of claims in this paper.

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